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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Choi et al.

**PATENT APPLICATION**

Serial No.: 09/698,317

Group Art Unit: 2834

Filed: Oct. 27, 2000

Examiner: Dougherty, Thomas M.

For: HIGH PRECISION ORIENTATION ALIGNMENT AND GAP CONTROL  
STAGES FOR IMPRINT LITHOGRAPHY PROCESSES

### AMENDMENT AFTER NOTICE OF ALLOWANCE

Commissioner  
for Patents  
Alexandria, VA 22313

Sir:

In response to the Notice of Allowance mailed

September 1, 2004, please amend the application as follows:

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after final amendment is approved.  
(It is ok to enter it.)